

Image
Attorney Docket
33082 M 112



1746
P A T E N T

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

CONFIRMATION NO. 6309

Applicant : Yuji KAMIKAWA
Serial No. : 10/024,175 Art Unit : 1746
Filed : December 21, 2001 Examiner : Frankie L. STINSON
For : System for Processing Substrate with Liquid

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir :

A response to the Office Action mailed March 8, 2004 is due by April 8, 2004.

The Action required restriction among Groups I-IV, as follows:

- Group I of claims 1-3, drawn to a system for processing a substrate, classified in class 134, subclass 201;
- Group II of claims 4-8, drawn to a system for processing a substrate, classified in class 134, subclass 58R;
- Group III of claims 9-12, drawn to a system for processing a substrate, classified in class 134, subclass 58R; and.
- Group IV of claims 13-24, drawn to a system for processing a substrate, classified in class 134, subclass 186.

Applicants hereby elect Group IV of claims 13-24, drawn to a system for processing a substrate, classified in class 134, subclass 186, for prosecution in this application.

Applicants reserve the right to file divisional application(s) for the non-elected claims in due course. Applicants submit that this application now is in condition for examination on the merits and early action in that regard is solicited.

Respectfully submitted,

SMITH, GAMBRELL & RUSSELL, LLP



Michael A. Makuch, Reg. 32,263
1850 M Street, NW – Suite 800
Washington, DC 20036
Tel : 202/263-4300
Fax : 202/263-4329

Date : April 2, 2004